

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Takashi Hamada et al.

Serial No: 10/051,064

Filed: January 18, 2002

Art Unit: 2823

Examiner: F. Toledo

For: SEMICONDUCTOR DEVICE
AND METHOD OF
MANUFACTURING THE SAME

Confirm no. 3404

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED

MAR 31 2004

OFFICE OF PETITIONS

I hereby certify that this correspondence is being sent
by facsimile to the Commissioner for Patents

March 29, 2004

(Date of Deposit)

Fax Number: (703) 308-6916

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 3/29/04
Signature Date

AMENDMENT B (AFTER ALLOWANCE)

Dear Sir:

In response to the Notice of Allowance of December 3, 2003, the issue fee having already
been paid and a RCE being submitted herewith, please amend the above-identified application as
follows.